Docket No.: 060188-0751

<u>PATENT</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Yoshiharu HIDAKA, et al.

Confirmation Number: 8259

Application No.: 10/754,518

Group Art Unit: 2814

Filed: January 12, 2004

Examiner: Thao X. Le

For: SEMICONDUCTOR SUBSTRATE, METHOD FOR FABRICATING THE SAME, AND

METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the

Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

10/754,518

CERTIFICATION PARAGRAPH

The undersigned certifies that each item of information contained in this Information

Disclosure Statement was first cited in a communication from a foreign patent office in a

counterpart foreign application not more than three months prior to the filing of this Information

Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application

office action and its relevance discussed therein. A copy of the foreign office action, is attached

for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper,

including extension of time fees, to Deposit Account 500417 and please credit any excess fees to

such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Please recognize our Customer No. 20277

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Facsimile: 202.756.8087 **Date: July 28, 2005**

as our correspondence address.

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INFORMATION DISCLOSURE					NI I		SERIAL NO. 10/754,518				
CITATION IN AN APPLICATION					000100-0731	000100-0731		1077 34,3 10			
, 3 8 2005 ±					APPLICANT Yoshiharu HII	APPLICANT Yoshiharu HIDAKA, et al.					
					EILING DATE	FILING DATE GROUP					
(PTO-1449) U.S. PATENT					January 12, 2004 2814						
U.S. PATENT DOCUMENTS											
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (# known)		Publication Dat MM-DD-YYYY		Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
		US 6,439,969 B1		08/27/2002	Koma et a	ıl,	Corresponds to CN 1267085 A				
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EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes -Number 4 -Kind Codes (if known)		Publication Date MM-DD-YYYY		Pages, Columns, Lines Where Relevant Figures Appear		Tra Yes	nslation No		
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)											
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EXAMINER						DATE CONSIDERED					

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.